

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) **CONFIRMATION NO.: 8170**

Hiroyuki MATSUURA

U.S. Serial No.: 10/563,208) **Group Art Unit: 3753**

Filed: January 3, 2006) **Examiner: Kevin L. Lee**

For: **PRESSURE REDUCTION PROCESS DEVICE, PRESSURE REDUCTION PROCESS
METHOD, AND PRESSURE REGULATION VALUE**

RESPONSE AS SUBMISSION UNDER 37 C.F.R. § 1.114

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A reply to the Office Action of December 21, 2010 was due by March 21, 2011.

Submitted herewith, together with the requisite fee, is a Petition for extending the time of reply up to and including June 21, 2011. Both this paper and the Petition are accompanied by a Request for Continued Examination (RCE) and its requisite fee. Please accept all of these papers as timely filed.